DT	^	4	_	n	=
	1 1.			м	: 1

RECORDATION FORM COVER SHEET U.S. DEPARTMENT OF COMMERCE Patent and Trad mark Office

PATENTS ONLY						
To the Honorable Commissioner of Patents and Trademarks: Plea	ase record the attached original documents or copy thereof.					
Name of conveying party(ies): Kuo-Feng Chen	2 Name and address of receiving party(les): Taiwan Semiconductor Manufacturing Co. Ltd. No. 121 Park Avenue 3					
Hsiu-Mei Yu Charles Tseng Ta-Yang Lin	Hsin-Chu, Taiwan, R.O.C.					
3 Nature of conveyance: ■ Assignment	Additional name(s) & address(es) attached □ Yes ⊠ No					
☐ Security Agreement ☐ Change of Name ☐ Other: Execution Date:						
Application number(s) or patent number(s): If this document is being filed together with a new application.	, the execution date of the application is:06-23-01					
A. Patent Application No(s).	B. Patent No(s)					
Additional numbers at	tached? □ Yes ⊠ No					
5 Name and address of party to whom correspondence concerning document should be mailed:	6 Total number of applications and patents involved: 1 7 Total foo (37 CER 3.41) \$40.00					
RANDY W. TUNG Tung & Associates 838 W. Long Lake Road Suite 120	7 Total fee (37 CFR 3.41) \$40.00					
Bloomfield Hills, Michigan 48302	Authorized to charge credit card (w/filing fee) Deposit Account Number: 50-0484					
	(Attach duplicate copy of this page if paying by deposit account)					
DO NOT US	E THIS SPACE					
9 Statement and signature. To the best of my knowledge and belief, the foregoing information the original document. Randy W. Tung Nam of Person Signing Signature	mation is true and correct and any attached copy is a true copy of January 12, 2002 Dat					
R gistration No. 31,311	mber of pages including cover shet, attachments, and document: 3					

Mail d cum nts to be record d with requir d c ver sheet information t : Commission r of Pat nts & Trad marks, B x Assignments Washington, D.C. 20231

ASSIGNMENT

WHEREAS, we, <u>KUO-FENG CHEN, HSIU-MEI YU, CHARLES TSENG and TA-YANG LIN</u> have invented certain improvements in

METHOD AND APPARATUS FOR PRETREATING A SUBSTRATE PRIOR TO ELECTROPLATING

for which we are about to make application for Letters Patent of the United States; and

WHEREAS, TAIWAN SEMICONDUCTOR MANUFACTURING CO., LTD. of No. 121, Park Avenue 3, Science-Based Industrial Park, Hsin-Chu, Taiwan, R.O.C, is desirous of acquiring the entire right, title and interest in and to said invention;

67,200-569 2000-0908

continuation or continuation-in-part application thereof, and in and to any reissue of any such patent, and in and to any patent applications which may be filed on said invention in countries foreign to the

United States and any Letters Patent granted thereon.

We further authorize said corporation to apply for foreign patents on said invention

in its own name or through its designees, including subsidiaries, related companies or assignees,

under the International Convention or otherwise, and we further agree to execute all papers,

including those required for the United States and foreign applications, and to perform such other

proper acts as said corporation or its designees the rights herein assigned.

Kuo-Fong Chen

Charles Tsang CHARLES TSENG

TUNG & ASSOCIATES 838 W. Long Lake Road Suite 120

Bloomfield Hills, Michigan 48302